



ELECTRONIC COPY

LG756595028
Report verification at igi.org



December 17, 2025
IGI Report Number **LG756595028**
Description **LABORATORY GROWN DIAMOND**
Shape and Cutting Style **CUT CORNERED
RECTANGULAR MODIFIED
BRILLIANT**
Measurements **7.19 X 5.11 X 3.39 MM**
GRADING RESULTS
Carat Weight **1.05 CARAT**
Color Grade **D**
Clarity Grade **VVS 2**
Cut Grade **EXCELLENT**

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IGI Report Number **LG756595028**
Description **LABORATORY GROWN DIAMOND**
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MODIFIED BRILLIANT**
Measurements **7.19 X 5.11 X 3.39 MM**

GRADING RESULTS

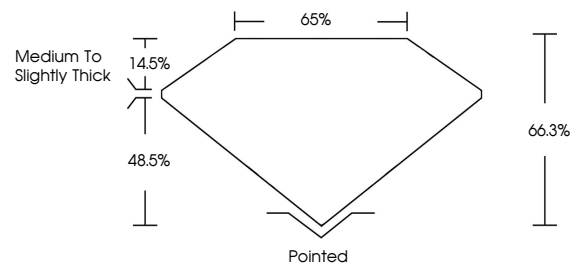
Carat Weight **1.05 CARAT**
Color Grade **D**
Clarity Grade **VVS 2**
Cut Grade **EXCELLENT**

ADDITIONAL GRADING INFORMATION

Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscription(s) **IGI LG756595028**

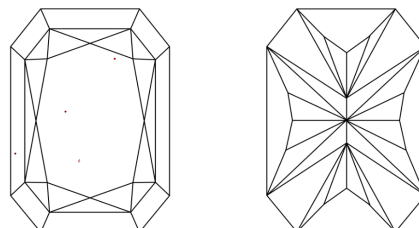
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa

PROPORTIONS



Sample Image Used

CLARITY CHARACTERISTICS



KEY TO SYMBOLS

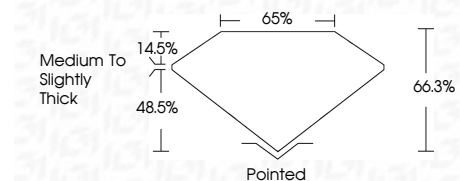
Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

COLOR

D E F G H I J Faint Very Light Light

CLARITY

FL	IF	VVS ¹⁻²	VS ¹⁻²	SI ¹⁻²	I ¹⁻³
Flawless	Internally Flawless	Very Very Slightly Included	Very Slightly Included	Slightly Included	Included



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Fluorescence **NONE**
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IGI



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CUT CORNERED RECT. MODIFIED BRILLIANT
7.19 X 5.11 X 3.39 MM
Carat Weight **1.05 CARAT**
Color Grade **D**
Clarity Grade **VVS 2**
Cut Grade **EXCELLENT**
Depth **66.3%**
Table **65%**
Girdle **Medium To Slightly Thick**
Culet **Pointed**
Polish **EXCELLENT**
Symmetry **EXCELLENT**
Fluorescence **NONE**
Inscriptions(s) **IGI LG756595028**
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process. Type IIa